

Fossum insulted in his 2014 paper Sony and Hagiwara 1975 PPD invention.

Indeed, Hagiwara invented PPD with VOD and the virtual charge transfer in 1975 !!

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Sony HAD (PPD+VOD) does not use LOCOS !!!

A Review of the Pinned Photodiode for CCD and CMOS Image Sensors

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Many people now said this is a fake paper !

False



C. Other Contributions to the PPD Invention

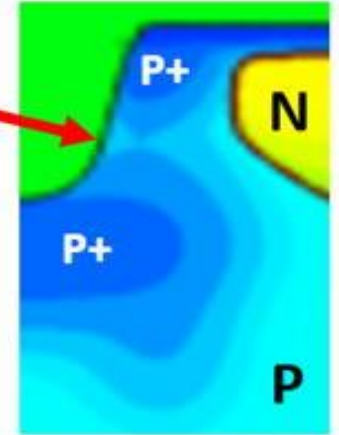
The PPD structure, while invented for low lag ILT CCD application, shares a strong resemblance to the Hyncecek virtual-phase CCD structure, with the exception of the VOD. The two inventions were solving different problems with essentially the same device structure and operating principles.

In 1975, Hagiwara at Sony filed a patent application on bipolar structures for CCDs in which a *pnp* vertical structure was disclosed, among several structures [24]. The top *p* layer was connected by metal to a bias used to control full-well capacity and the *n*-type base layer was proposed for carrier storage. In an unusual paper, Hagiwara, in 1996, revisited the 1975 invention and claimed it was essentially the invention of both the virtual phase CCD and the NEC low-lag structures, as well as the basis of the Sony so-called "Hole Accumulation Diode," or HAD structure [25]. However, the 1975 application

did not address complete charge transfer, lag or anti-blooming properties found in the NEC low-lag device, and does not seem to contain the built-in potential step and charge transfer device aspects of the virtual-phase CCD. Hagiwara repeats these claims in a 2001 paper [26] and shows a VOD structure that is not found in the 1975 patent application. Sony did not seem to pursue the HAD structure until well after the NEC paper was published. However, the "narrow-gate" CCD with an open *p*-type surface region for improved QE also disclosed in the 1975 application was reported in more detail by Hagiwara et al. at Sony in 1978 [27]. A similar structure was used extensively by Philips [28].

The PPD, as it is most commonly used today, bears the strongest resemblance to the Teranishi et al. ILT CCD device. Thus, these days Teranishi is considered as the primary inventor of the modern PPD [29].

The surface P+ layer is NOT connected to the LOCOS P+ layer. The surface P+ layer may be floating and this photodiode may have serious image lag.



Serious Image Lag ?

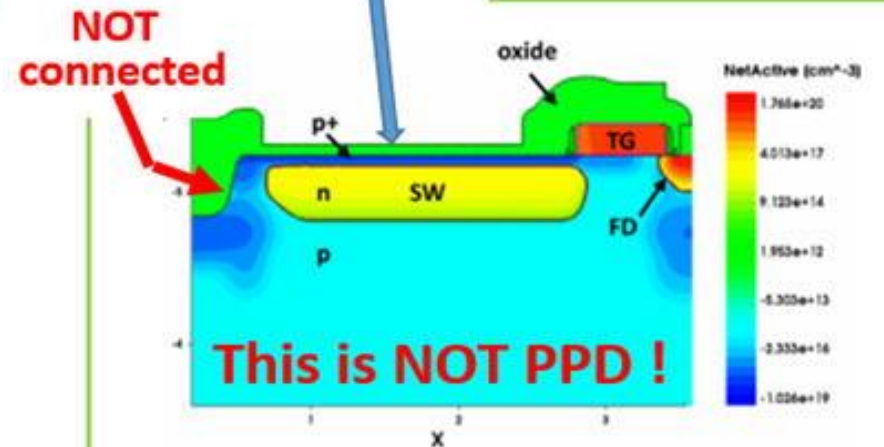


Fig. 4. Example of a pinned photodiode implemented in a CMOS image sensor showing doping concentrations. (Dimensional units are microns).

Hagiwara in 1975 invented PPD with VOD and the virtual charge transfer. Study the Japanese Patents 1975-127646, 1975-127647 and 1975-134985.